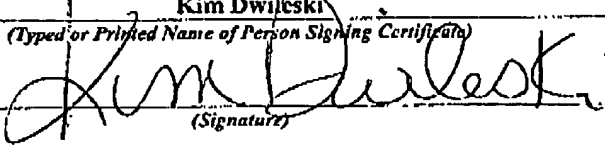


CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			Docket No. BUR920030189US1	
Applicant(s): Anthony J. Stamper				
Application No. 10/709,722	Filing Date 5/25/2004	Examiner Chu, Chris C.	Group Art Unit 2815	
Invention: METHOD OF FORMING A SEMICONDUCTOR DEVICE HAVING AIR GAPS AND THE STRUCTURE SO FORMED				
<div style="text-align: right;">RECEIVED CENTRAL FAX CENTER FEB 02 2006</div>				
I hereby certify that this <u>Request for Reconsideration (13 pages)</u> <small>(Identify type of correspondence)</small>				
is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>571-273-8300</u>)				
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DOCKET NO.: BUR920030189US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Anthony K. Stamper

Examiner: Chu, Chris C.

Serial No.: 10/709,722

Art Unit: 2815

Filed: 05/25/2004

**Title: METHOD OF FORMING A SEMICONDUCTOR DEVICE HAVING AIR GAPS
AND THE STRUCTURE SO FORMED**

Commissioner for Patents
P.O. Box 1450
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REQUEST FOR RECONSIDERATION

Sir:

This Request for Reconsideration is in response to the Final Office Action mailed
December 16, 2005.

10/709,722

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